

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/567173 Confirmation No. 9635
First Inventor : AMATO, Joseph M.
Filed : February 3, 2006
TC/A.U. : 2823
Examiner : LEE, Hsien Ming

Docket No. : **US03 0199 US2**
Customer No. : 65913

Title: Offset Dependent Resistor for Measuring Misalignment of
Stitched Masks

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO REQUIREMENT FOR RESTRICTION

Sir:

In response to the Non-Final Office Action of July 8, 2008, in which a restriction requirement has been presented, the claims of Group I are hereby elected with traverse. Please consider the Remarks that follow beginning on page 2 of this paper. Also included in this response is an Information Disclosure Statement.